

## Develop Capability of Photopatterning

The Ewha ADL team has 2 automatic developers and can experiment with wafers ranging from piece-scale wafers up to 4-inch scale wafers.

	# of Owned	Substrate Size	Spin Speed	Bowl Size	# of Recipe	Bowl Material
SSP200 	1 (Only for positive tone)	2~6 inch (Glass, Si Wafer)	300 ~ 6,000 rpm	8 inch	50 steps 50 Recipes	polypropylene
LSD 150 	1 (Only for Negative tone)	2~6 inch (Glass, Si Wafer)	300 ~ 7,000	8 inch	100 steps 100 Recipes	polypropylene